

## RECEIVED DLC 0 4 2003

TC 1700

PATENT 1592-0131P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Shigeto FUJIMURA et al. Conf.:

Appl. No.:

09/753,662

Group:

1765

Filed:

January 4, 2001

Examiner: M. A. ANDERSON

For:

PROCESS FOR PRODUCING COMPOUND

SEMICONDUCTOR CRYSTAL

## PETITION TO WITHDRAW OFFICE ACTION MAILED AUGUST 21, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 November 21, 2003

Sir:

Submitted herewith is a petition under 37 C.F.R. § 1.59(b) to withdraw the Office Action mailed August 21, 2003.

A check in the amount of \$130.00 is enclosed.

11/25/2003 WABDELR1 00000073 09753662

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130.00 OP